

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Patent Application Serial No. 10/612,836
Filing Date July 3, 2003
Inventor R. Weimer
Assignee Micron Technology, Inc.
Group Art Unit 2813
Examiner S.W. Smoot
Attorney Docket No. MI22-2263
Title: Methods of Forming Deuterated Silicon Nitride Containing Materials

NOV 12 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 CFR § 1.8

I hereby certify that the following papers are being facsimile transmitted to the Patent and Trademark Office at (703) 872-9306 on the date shown below:

1. Certificate of Facsimile Transmission
2. Response to September 22, 2004 Office Action

Dated: November 12, 2004By: 

Jennifer Gaines, Legal Assistant
Telephone No. (509) 624-4278
Facsimile No. (509) 838-3424

FEE DEFICIENCY

Although it is believed that no fees are due, the Commissioner is hereby authorized to charge any fees under 37 C.F.R. 1.16 and 1.17 which may be required by this paper to Deposit Account No. 23-0925.

Dated: November 12, 2004By: 

David G. Latwesen, Ph.D.
Reg. No. 38,533

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No.10/612,836
Confirmation No.7185
Filing Date July 3, 2003
Inventor..... Ronald A. Weimer
Assignee.....Micron Technology, Inc.
Group Art Unit.....2813
Examiner Stephen W. Smoot
Attorney's Docket No.MI22-2263
Customer No.021567
Title: Methods of Forming Deuterated Silicon Nitride Containing Materials

RESPONSE TO SEPTEMBER 22, 2004 OFFICE ACTION

To: Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

From: David G. Latwesen, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)
Wells St. John P.S.
601 W. First Avenue, Suite 1300
Spokane, WA 99201-3828

AMENDMENTS

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